



Docket No. F-7041

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Kiyohiko TAKAGI, et al.  
Serial No. : 09/892,023  
Filed : June 26, 2001  
For : DRYING ETCHING METHOD  
Group Art Unit : 2823  
Examiner : William D. Coleman  
Confirmation No. : 1827  
Customer No. : 000028107

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Lawrence I. Wechsler  
(Name)

January 8 2004  
(Signature)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

04/21/2004 SDENR0B1 00000001 101250 09892023

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**INTRODUCTORY COMMENTS:**

Sir:

In response to the Office Action of November 14, 2003, please amend the above-identified patent application as follows: